

FORM PTO/SB/08A/B (10-01) Substitute for PTO-1449A/B	Attorney Docket Number	56136/DBP/N75
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)	Application Number	N/A
	Filing Date	October 7, 2005
	Applicant(s)	Maxime Makarov, et al.
	Group Art Unit	N/A
	Examiner Name	N/A

U.S. PATENT DOCUMENTS				
EXAMINER INITIALS	Cite No. ¹	DOCUMENT NUMBER Number - Kind Code ² (If Known)	Publication Date MM-DD-YYYY	Name of Patentee
/PS/		5,048,045	09-10-1991	Noda, et al.
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/PS/		EP 0 496 438 A1	07-29-1992	Stegehuis	
/PS/		JP 2002 170767 (ON ORDER)	06-14-2002	Nakasuji	Patent Abstract of Japan

OTHER DOCUMENTS		
EXAMINER INITIALS	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		International Search Report dated 02-01-2005 corresponding to PCT/FR2004/000557
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